



Attorney Docket No. SON-1690 Date: November 1, 1999



Sir:

Transmitted herewith for filing is the patent application of

Inventor: ICHIRO FUJIWARA

For: NONVOLATILE SEMICONDUCTOR MEMORY DEVICE AND PROCESS OF

PRODUCTION AND WRITE METHOD THEREOF

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X	Specification	and Claim(s).
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- ☑ Oath or Declaration (unexecuted).
- Eighteen sheet(s) of drawings.
- ☐ An assignment of the invention to _____
- ☐ Copy of ______ priority application(s).
- ☐ Associate Power of Attorney.

The fee has been calculated as shown below:

CLAIMS AS F	FILED			
			RATE	BASIC FEE
FOR	NUMBER FILED	NUMBER EXTRA		\$380/\$760
TOTAL			X \$ 9	
CLAIMS	51-20	31	\$18	\$558.00
INDEP.			X \$39	
CLAIMS	6-3	3	\$78	\$234.00
Fee for Multiple Dependent Claims \$130/\$260			0	
			TOTAL	
			FILING FEE	\$1552.00

	A Preliminary Amendment is attached.	
	Verified Statement claiming small entity status is enclosed.	
X	Charge \$ 1552.00 to Deposit Account No. 18-0013 to cover the filing fee. A duplicate copy of this sheet is enclosed.	
X	The Commissioner is hereby authorized to charge any fees under 37 C.F.R. 1.16 or 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 18-0013. A duplicate copy of this sheet is enclosed.	
	A check in the amount of \$ cover the filing fee is enclosed.	
	Charge \$ to Deposit Account No. 18-0013 to cover the recordal fee. A duplicate copy of this sheet is enclosed.	
X	Applicant's undersigned attorney may be reached by telephone in our Washington D.C. Office at	
(202) 955-3750.		
All correspondence should be directed to our below listed address.		
	Ronata P. Kananen Reg. No. 24,104	

RADER, FISHMAN & GRAUER, P.L.L.C 1233 20th Street, NW, Suite 501 Washington, DC 20036 Telephone: (202) 955-3750 Facsimile: (202) 955-3751